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| Substitute for Form 1449 A & B/PTO <u>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</u> <i>(use as many sheets as necessary)</i> | | | | <i>Complete if Known</i> | |
| | | | | Application Number | 10/579,406 |
| | | | | Confirmation Number | 1349 |
| | | | | Filing Date | May 15, 2006 |
| | | | | First Named Inventor | Nobuo UOTANI |
| | | | | Art Unit | 2812 |
| | | | | Examiner Name | not yet assigned |
| Sheet | 1 | of | 1 | Attorney Docket Number | Q78564 |

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NON PATENT LITERATURE DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published. | Translation ⁶ |
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| Examiner Signature | /Pegah Parvini/ | Date Considered | 12/19/2008 |
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